

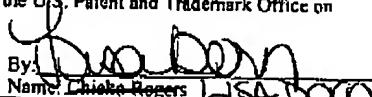
S/N 10/804,610

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	KITAOKA, ET AL.	Examiner:	TU TU V. HO
Serial No.:	10/804,610	Group Art Unit:	2818
Filed:	MARCH 18, 2004	Docket No.:	10873.1420US01
Title:	METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on February \_\_\_\_\_, 2006.

By:   
Name: LISA DORN

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop: AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Office Action mailed September 22, 2005, with the time for response extended with a two-month extension of time from December 22, 2005 to February 22, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the Listing of Claims that begins on page 2 of this paper.

**Remarks** begin on page 11 of this paper.